 Advanced Instrumentation Research Facility

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**Workshop on “Field Emission Scanning Electron Based Lithography” to be held on 5th – 6th September, 2019**

**APPLICATION FORM**

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| **Name of the Applicant** |  | |
| **Gender (Tick)** | **Male** | **Female** |
| **Name of the Supervisor /Mentor with telephone no.** |  | |
| **Complete Address of Workplace** |  | |
| **E - mail address**  **Mobile No.** |  | |
| **Educational Background (Bachelors onwards)** |  | |
| **Please describe how your current work is related “Field Emission Scanning Electron Microscopy Based Lithography”** | | |
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| **Have you previously attended any Workshop at AIRF? (if YES mention the details)** |  | |

**(Signature of the candidate) (Signature with stamp)**

Date: **(Supervisor / Dean)**

Place:

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**(For AIRF Office Use Only)**

S. No. \_\_\_\_\_\_\_\_\_\_\_\_\_\_\_\_\_\_\_\_ Dated: \_\_\_\_\_\_\_\_\_\_\_\_\_\_

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| Selected | In waiting |

(**DIRECTOR, AIRF)**